

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/783,244	<b>Applicant(s)/Patent under Reexamination</b> KIM ET AL.
	<b>Examiner</b> Ryan Lepisto	<b>Art Unit</b> 2883

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
385	128	2/6/06	Ron
See interference search printouts		2/6/06	Ron